

Toxic gas or Semiconductor manufacturing ga	H ₂ Hydrogen	Explosion Prevention
Poisoning Prevention	Gas Leak Detection	

Model	XP-703DIII
Gas Detected	Hydrogen, Arsine, Diborane, Silane and Phosphine
Detection Principle	Hot-wire semiconductor sensor
Sampling Method	Extractive
Weight	Approx. 190g (including batteries and soft case)

To detect trace amounts of various semiconductor manufacturing gases.

Applications

- For gas leak inspection at semiconductor factory where there is toxic gas.
 Safety for hydrogen-related equipment.

Features

- · Can detect trace amounts of various semiconductor manufacturing gases.
- Automatic stop pump function
- · Automatic gas exhaust mode
- Equivalent to IP22 (in soft case)

Specifications

Model	XP-703DIII	
Gas Detected	Hydrogen, Arsine, Diborane, Silane and Phosphine	
Detection Principle	Hot wire semiconductor sensor	
Sampling Method	Extractive	
Detectable Leak Rate	H ₂ : 5.07 x 10-7, AsH ₃ : 2.53 x 10-7, B ₂ H ₆ : 1.01 x 10-7, SiH ₄ : 2.53 x 10-7, PH ₃ : 1.52 x 10-7	
Detectable Gas Concentration	H ₂ : 1.0ppm, AsH ₃ : 0.5ppm, B ₂ H ₆ : 0.2ppm, SiH ₄ : 0.5ppm, PH ₃ : 0.3ppm	
Response Time	Within 10 seconds (for 300% of detectable gas concentration)	
Power Supply	Size AA alkaline batteries x 2	
Battery Life*1	Approx. 12 hours (with size AA alkaline batteries)	
Degree of Protection	Equivalent to IP22	
Operating Pressure	Atmospheric pressure (800 to 1100 hPa)	
Operating Temperature/Humidity	0 to +40°C Less than 85%RH (with no condensation)	
Dimensions	Approx. W38 x H130 x D32 mm (excluding protrusions)	
Weight	Approx. 190g (including batteries and soft case)	
Accessories	Soft case, Drain Filter, Replacement Filter, Gas Probe, Dust Filter, Hand Strap, Size AA Alkaline Battery x 2, etc.	

^{*1} It may vary based on the environmental conditions, operating conditions, strage time, battery manufacturer, etc.